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APPLICANTS	•			*	•			
	antina Davind Laka NIV		ll ye	2				
Arne vv. Ball	antine, Round Lake, NY;		. ,					
Jeffrey D. Gil Glen L. Miles James J. Qu Samuel C. R Michael B. R	in, Staten Island, NY; bert, Burlington, VT;Kevin M. , Essex Junction, VT; inlivan, Essex Junction, VT; amac, Essex Junction, VT; ice, Colchester, VT; d, Essex Junction, VT;	Houlihan, E	Boston, MA;					
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ADDRESS 30678 CONNOLLY BOVE SUITE 800 1990 M STREET N' WASHINGTON, D 20036-3425								
TITLE Method of reducina	polysilicon depletion in a poly	silicon gate	electrode by de	epositina polvs	ilicon of var	vina arai	n size	
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